

	INFORMATION DISCLOSURE CITATION	Attorney Docket No.: 46884-5429	Serial No.: 10/551,195
	(Use several sheets if necessary)	Applicants: Seiichi NAGATA	Page 1 of 1
	PTO Form 1449	Filing Date: April 27, 2007	Group Art Unit: 1794

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/JL/	Seiichi Nagata, et al., "Single-Mode Optical Waveguide Fabricated by Oxidization of Selectively Doped Titanium Porous Silicon," Vol. 72, No. 23, June 8, 1988, Applied Physics Letters, AIP, American Institute of Physics, Melville, NY. Pgs. 2945-2947, ISSN: 0003-6951, XP012020366.
/JL/	R. Narendra, et al., "Single-Mode, Phosphorus-Doped Silica Waveguides in Silicon V-Grooves," Vol. 5, No. 1, January 1993, IEEE Photonics Technology Letters, IEEE Service Center, Piscataway, NJ. Pgs. 43-46. ISSN: 1041-1135. XP000335394.

Examiner /Jonathan Langman/

Date Considered	12/30/2008
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Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /JL/